

03560.002760.

*Ifw 2851*
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shuichi YABU

Application No.: 09/811,447

Filed: March 20, 2001

For: EXPOSURE APPARATUS, GAS REPLACING
METHOD, AND METHOD OF MANUFACTURING
A SEMICONDUCTOR DEVICE

)
: Examiner: A. Mathews
)
: Group Art Unit: 2851
)
: Confirmation No.: 9561
:
)
:
)

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment in the above-identified application.

 No additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	87	MINUS	68	= 19	x \$9 \$18	\$342.00
INDEP. CLAIMS	22	MINUS	20	= 2	x \$42 \$84	\$168.00
Fee for Multiple Dependent claims \$140/\$280						—
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$510.00

- °Verified Statement claiming small entity status is enclosed, if not filed previously.
- A check in the amount of \$510.00 is enclosed.
- Charge \$____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- A check in the amount of \$_____ to cover the fee for a _____ month extension is enclosed.
- A check in the amount of \$____ to cover the Information Disclosure Statement fee is enclosed.
- Applicant's attorney, Steven E. Warner, may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.
- Respectfully submitted,
- 

Attorney for Applicant
Jack S. Curbert
Registration No. 24,245

FITZPATRICK, CELLA, HARPER & SCINTO
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SEW/eab

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Shuichi YABU) Examiner: A. Mathews
Application No.: 09/811,447) Group Art Unit: 2851
Filed: March 20, 2001) Confirmation No.: 9561
For: EXPOSURE APPARATUS, GAS)
REPLACING METHOD, AND METHOD : June 2, 2004
OF MANUFACTURING A)
SEMICONDUCTOR DEVICE :
:

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action dated March 2, 2004, please amend the above-identified application as follows:

06/04/2004 MMERONEN 00000058 061205 09811447
01 FC:1201 110.00 OP
02 FC:1202 4.00 DA 338.00 OP

06/04/2004 MMERONEN 00000058 061205 09811447

01 FC:1201 172.00 OP
02 FC:1202 4.00 DA 338.00 OP